ECE-305: Spring 2018

Carrier Action

Pierret, Semiconductor Device Fundamentals (SDF) Chapter 2 (pp. 22-49) Chapter 3 (pp. 75-89)

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outline

- 1. Carrier distributions
- 2. Carrier concentrations
- 3. Current (drift)
- 4. Mobility, resistivity, etc.

Carrier Distribution Depends on Fermi Level

These states are way above the Fermi level. E_{C} Typically, we will find the $E_G = 1.1 \,\mathrm{eV}$ Fermi level somewhere inside the bandgap. inside the bandgap. E_{V} These states are way below the Fermi level.

energy band diagram of an intrinsic semiconductor



Carrier Distribution



Fermi energy near mid-gap

Carrier Distribution



Fermi energy below mid-gap

Carrier Distribution



Fermi energy above mid-gap

Carrier Distribution: Boltzmann Approximation

Obtained by integrating carrier distribution using Boltzmann approximation



Density of states (electrons)

$$n = N_C e^{(E_F - E_C)/k_B T} \qquad N_C = 2 \left[\frac{\left(m_n^* k_B T\right)}{2\pi\hbar^2} \right]^{3/2}$$
 "effective density of states"
$$E_C - E_F > 3k_B T$$

For Si at T = 300K: $m_n^* = 1.182$ (DOS effective mass)

$$N_C = 3.23 \times 10^{19} \text{ cm}^{-3}$$

Fermi level should be at least $3k_BT$ away from a band edge.



Density of states (holes)





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Carrier Concentration in Intrinsic Semiconductors

$$n = p = n_{i}$$

$$n \times p = N_{C}e^{-(E_{C}-E_{F})/k_{B}T} \times N_{V}e^{-(E_{F}-E_{V})/k_{B}T}$$

$$= N_{C}N_{V}e^{-(E_{C}-E_{V})/k_{B}T}$$

$$= N_{C}N_{V}e^{-E_{g}/k_{B}T}$$

$$= n_{i}^{2}$$

$$n_{i} = \sqrt{N_{C}N_{V}}e^{-E_{g}/2k_{B}T}$$
(Eq. from Ex. 2.4
Includes temp.-dependent
changes in effective mass)

$$n_{i}(Si) = 9.15 \times 10^{19} \left(\frac{T}{300}\right)^{2}e^{-1.12/2k_{B}T}$$
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Fermi Level for Intrinsic Semiconductors

$$n_{i} = \sqrt{N_{C}N_{V}}e^{-E_{g}/2k_{B}T}$$

$$E_{F} \equiv E_{i}$$

$$n = p \Longrightarrow N_{C}e^{-(E_{c}-E_{i})/k_{B}T} = N_{V}e^{+(E_{v}-E_{i})/k_{B}T}$$

$$E_{i} = \frac{E_{G}}{2} + \frac{k_{B}T}{2}\ln\frac{N_{V}}{N_{C}}$$

$$N_{C} = 2\left(\frac{m_{i}^{*}k_{B}T}{2\pi\hbar^{2}}\right)^{3/2}$$

$$N_{V} = 2\left(\frac{m_{i}^{*}k_{B}T}{2\pi\hbar^{2}}\right)^{3/2}$$

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carrier densities (given doping)

A bulk material must be charge neutral overall ...

$$\int \left[p - n + N_D^+ - N_A^- \right] dV = 0$$

Further if the material is spatially homogenous and field free:



Once you know E_F , you can calculate n, p, N_D^+ , N_A^- . Bulk homogenous material has only one Fermi level.

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carrier densities (more generally)



Important Approximate Cases

$$n = \frac{N_D - N_A}{2} + \left[\frac{(N_D - N_A)^2}{4} + n_i^2\right]^{1/2} \qquad p = \frac{n_i^2}{n} \quad \text{(at equilibrium)}$$

Intrinsic Semiconductor: $N_D \ll n_i$, $N_A \ll n_i$

$$n pprox n_i$$
 , $p pprox n_i$

N-doped semiconductor: $N_D \gg n_i$ $N_D > N_A$ $n \approx N_D$ $p \approx n_i^2 / N_D$

P-doped semiconductor: $N_A \gg n_i$ $N_A \gg N_D$ $n \approx n_i^2 / N_A$ $p \approx N_A$

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semiconductor in equilibrium



 $v_{rms} \approx 10^7 \text{ cm/s} (T = 300 \text{ K})$

current flow



drift current and velocity



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drift current



resistance



24 1/18/2018 Definition of Conductivity and Resistivity

$$J_{n} = qn\mu_{n} \mathcal{E} \equiv \sigma_{n} \mathcal{E}$$
$$\sigma_{n} \equiv qn\mu_{n}$$
$$\mathcal{E} = (1/qn\mu_{n})J_{n} \equiv \rho_{n}J_{n}$$
$$\rho_{n} \equiv \frac{1}{qn\mu_{n}}$$

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current, conductivity, resistivity



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Drift by Electric field



Mobility and Physics of Scattering Time



Units of mobility

 $\upsilon \equiv \mu_n \mathcal{E}$



unit of mobility: cm²/V.s

$$\upsilon = \mu_n \mathcal{E}_{\dots} \frac{\mathrm{cm}^2}{\mathrm{volt} \times \mathrm{sec}} \times \frac{\mathrm{volt}}{\mathrm{cm}} \to \frac{\mathrm{cm}}{\mathrm{sec}}$$

$$\mu_n = \frac{q\tau_n}{m_n^*} = \frac{(qV)\tau_n \upsilon^2}{V\frac{m_n^* \upsilon^2}{2}} = \frac{J \times \sec \times \operatorname{cm}^2 / \sec^2}{\operatorname{volts} \times J}$$

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velocity and electric field



Velocity Saturation in Si/Ge



Velocity Overshoot & Inter-valley Transfer



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Multiple Scattering Events

Ionized impurity
 Phonon scattering
 others

$$\frac{1}{\mu_n} = \frac{1}{\mu_{ph}} + \frac{1}{\mu_{II}}$$
$$\Rightarrow \mu_n = \frac{\mu_{ph} \mu_{II}}{\mu_{ph} + \mu_{II}}$$
$$= \mu_{\min} + \left(\frac{\mu_{ph} \mu_{II}}{\mu_{ph} + \mu_{II}} - \mu_{\min}\right)$$
$$= \mu_{\min} + \left(\frac{\mu_0}{1 + (N_I/N_0)^{\alpha}}\right)$$



Matthession Rule

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Temperature-dependent Mobility



Phonon and Ionized Impurity Scattering

Ionized impurity

$$\tau_n \sim \frac{T^{3/2}}{N_D}$$



Higher temperature, more phonon scattering



 $\tau_n \sim T^{-3/2}$

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mobility vs. temperature



Model for Ionized impurity Scattering

from R.F. Pierret, Semiconductor Device Fundamentals, Fig. 3.5 (a)



Si carrier mobility vs. doping



from R.F. Pierret, Semiconductor Device Fundamentals, Fig. 3.5 (a)

Doping dependent Resistivity



summary

- 1) In <u>equilibrium</u>, the Fermi level and temperature gives the probability that a state at energy, *E*, is occupied by an electron or hole
- 2) Multiplying with the density of states yields the carrier densities
- 3) One can also work backwards from doping to calculate carrier densities and thus Fermi energy
- 4) Can calculate conductivity from carrier densities; can then use Ohm's law to calculate current
- 5) Conductivity can depend on electric field, doping, and temperature, which is all captured as carrier *mobility*